

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Nguyen, et al.

Serial No.: 09/912,103

Confirmation No.: 4476

Filed:

July 23, 2001

For:

Selective Etching of

Organosilicate Films Over Silicon Oxide Stop Etch

Layers

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Group Art Unit: 2823

Examiner:

Kheim D. Nguyen

MAIL STOP AMENDMENT Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450 CERTIFICATE OF MAILING 37 CFR 1.8

I hereby certify that this correspondence is being deposited on May 20, 2005 with the United States Postal Service as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

May **2.0**, 2005

Signature

Dear Sir:

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

The Applicants, and the Attorney who signs below on the basis of the information supplied by the inventor and the information in his file, submit herewith patents, publications, or other information of which they are aware, which may be material to the examination of this application and in respect of which there may be a duty to disclose in accordance with 37 CFR § 1.56.

While the information submitted in this Supplemental Information Disclosure Statement may be material pursuant to 37 CFR § 1.56, it is not intended to constitute an admission that any patent, publication, or other information referred to therein is prior art for this invention unless specifically designated as such.

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In accordance with 37 CFR § 1.97, this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or that no other possibly material information as defined under 37 CFR § 1.56(a) exists.

The patents and/or publications submitted herewith are set forth on the attached Form PTO-1449.

The Commissioner is hereby authorized to charge the sum_of \$180.00 due under 37 CFR § 1.17(p) pursuant to § 1.97, and any other fee necessary to make this submission timely, to the Deposit Account No. 20-0782/AMAT/5619/KMT.

Respectfully submitted,

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PTO/SB/08a (08-03)

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SUPPLEMENTAL INFORMATION **DISCLOSURE** STATEMENT BY APPLICANT

Complete if Known Application Number 09/912,103 Filing Date July 23, 2001 First Named Inventor Nguyen, et al. 2823 Art Unit Examiner Name Khiem D. Nguyen

(Use as many sheets as necessary)

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Sheet of 1 AMAT/5619/DSM/LOW K/JW Attorney Docket Number

			U.S. PATENT [OCUMENTS		
Examiner Initials *	Cite No.1	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevan Passages or Relevant Figures Appear	
		Number - Kind Code ² (if known)				
	A1	US-6,147,009	11/14/2000	Grill, et al.		
	A2	US- 6,140,226	10/31/2000	Grill, et al.		
	А3	US- 6,054,379	04/25/2000	Yau, et al.		
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FOREIGN PATENT DOCUMENTS								
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		Country Code ³ - Number ⁴ - Kind Code ⁵ (<i>if known</i>)						

Examiner Signature	 Date Considered	

This collection of information is required by 37 CFR 1.97 and 1.98. The information is required to obtain or retain a benefit by the public which is to file (and by the USPTO to process) an application. Confidentiality is governed by 35 U.S.C. 122 and 37 CFR 1.14. This collection is estimated to take 2 hours to complete, including gathering, preparing, and submitting the completed application form to the USPTO. Time will vary depending upon the individual case. Any comments on the amount of time you require to complete this form and/or suggestions for reducing this burden, should be sent to the Chief Information Officer, U.S. Patent and Trademark Office, U.S. Department of Commerce, P.O. Box 1450, Alexandria, VA 22313-1450. DO NOT SEND FEES OR COMPLETED FORMS TO THIS ADDRESS. SEND TO: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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